

Fig. 1

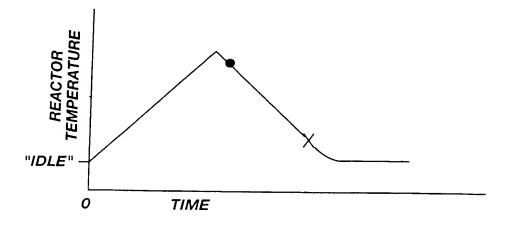


Fig. 3

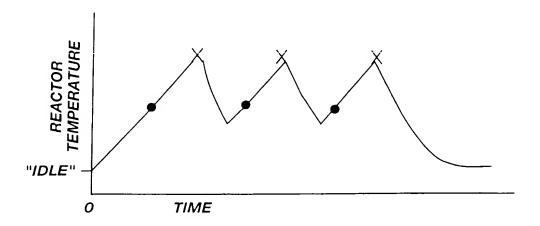


Fig. 2

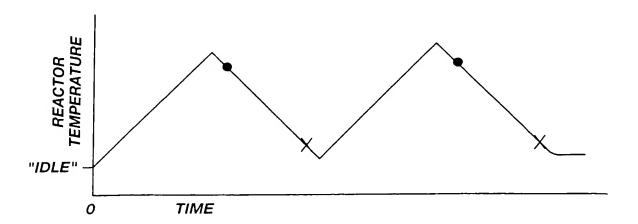


Fig. 6

## TITLE: PROCESS FOR FABRICATING FILMS OF UNIFORM PERTIES ON SEMICONDUCTOR DEVICE Inventor: Mercaldi et al. Docket No.: 3364.5US

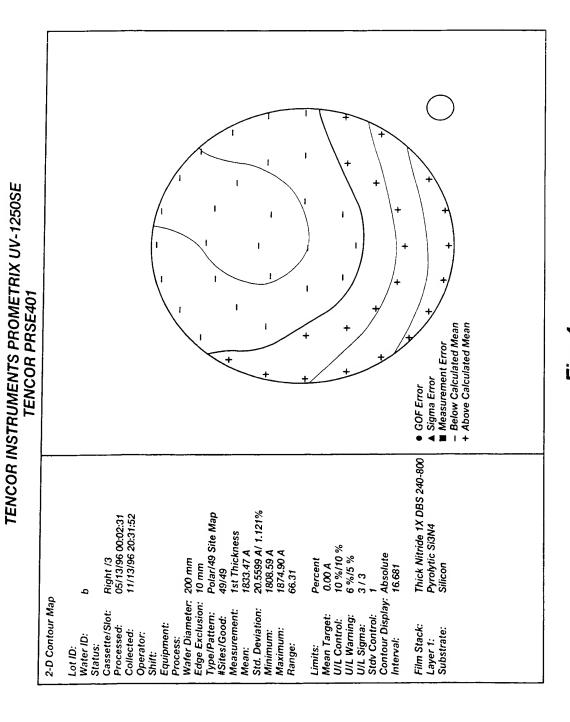


Fig. 4 (PRIOR ART)

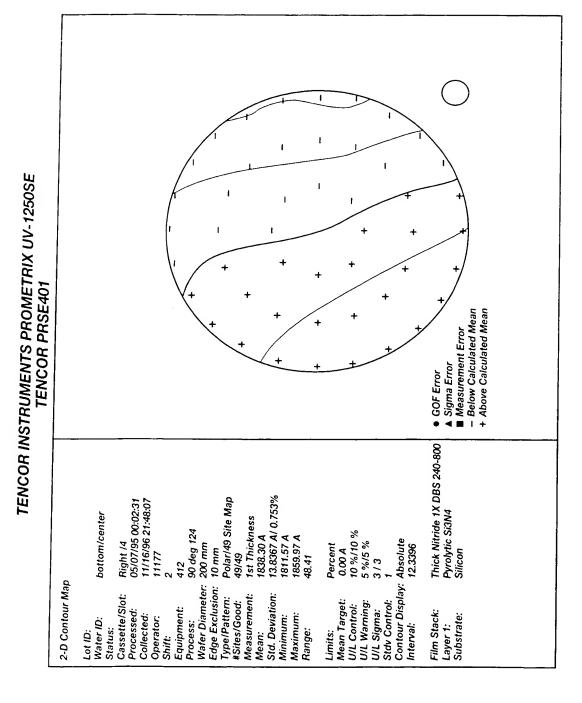


Fig. 5

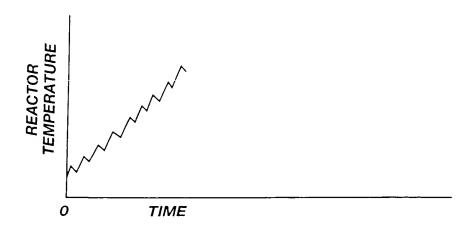


Fig. 7

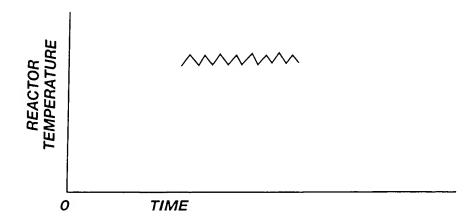


Fig. 8

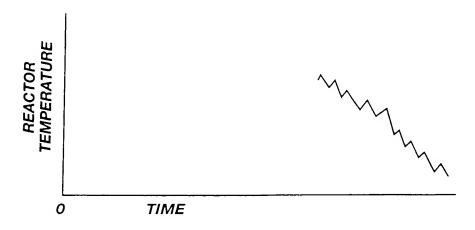


Fig. 9

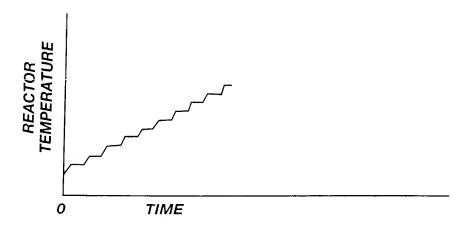


Fig. 7a

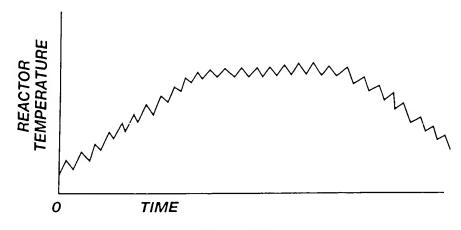


Fig. 10a

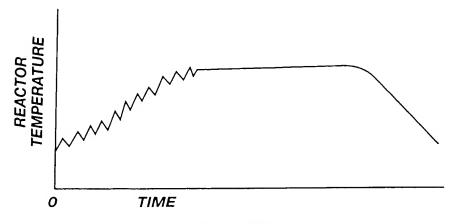


Fig. 10b

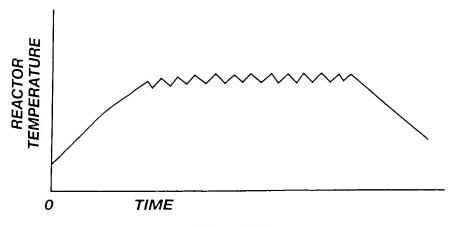


Fig. 10c

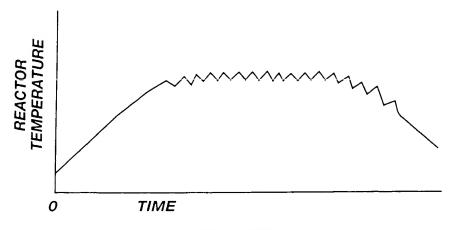


Fig. 10d

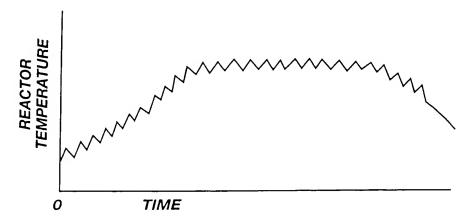


Fig. 10e

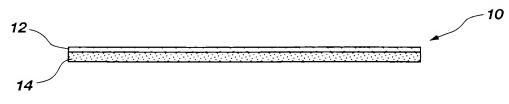


Fig. 11

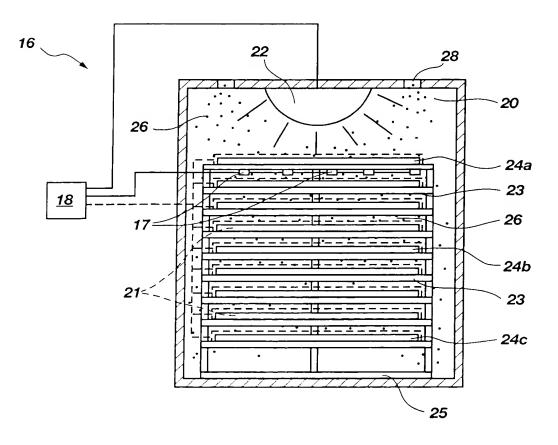


Fig. 12